



ASMTUT.2DVCP1

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Bogart et al.  
Appl. No. : 10/816,340  
Filed : March 31, 2004  
For : MEANS TO IMPROVE CENTER  
TO EDGE UNIFORMITY OF  
ELECTROCHEMICAL  
MECHANICAL PROCESSING OF  
WORKPIECE SURFACE (as  
amended)  
Examiner : Wilkins III, Harry D.  
Group Art Unit : 1742

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

September 26, 2006

(Date)

Tina Chen, Reg. No. 44,606

**AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. § 1.312**

**Mail Stop Issue Fee**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Please amend the above-captioned application as set forth herein.

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.